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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hitoshi YAMADA et al.**

Group Art Unit: **1762**

Application Number: **10/642,271**

Examiner: **Marianne L. Padgett**

Filed: **August 18, 2003**

Confirmation Number: **2420**

For: **METHOD OF FORMING METAL OXIDE FILM AND METHOD
FOR FORMING SECONDARY ELECTRON EMISSION FILM IN
GAS DISCHARGE TUBE**

Attorney Docket Number: **030933**
Customer Number: **38834**

SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

October 27, 2006

Sir:

In response to the Notice of Non-Compliant Amendment dated October 17, 2006, Applicants resubmit the listing of claims, which begin on page 2 of this paper.

Remarks begin on page 4 of this paper.